CS98-076 RIAL'NO.

JAN 2 8 2006

: 09/262,000

TO:

COMMISSIONER OF PATENTS AND TRADEMARKS

Washington, D.C. 20231

From : George O. Saile (Reg. No. 19,572)

28 Davis Avenue

Poughkeepsie, NY 12603

Date:

December 25, 2002

REF:

APPLICANT

: Kong, Sik On

SERIAL NO.

: 09/262,000

ART UNIT

: 2822

FILING DATE : 03/05/99

ATT'Y NO.

: CS98-076

EXAMINER

: Vockrodt, Jeff B.

TITLE

: PHOTOLITHOGRAPHIC METHODS FOR MAKING LIQUID-CRYSTAL-ON-SILICON DISPLAYS WITH ALIGNMENT

POSTS AND OPTICAL INTERFERENCE LAYERS

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to an office action mailed on 11/22/02please consider the following amendments and remarks with respect to the above referenced application.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal service as First Class mail in an envelop addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231, on January 22,2003.

Stephen B. Ackerman (Reg. No 37,761)

Signature

Date

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